## Notice of References Cited Application/Control No. 10/574,369 Examiner WEI LI Applicant(s)/Patent Under Reexamination MOSHAL, JOHN HILLEL Art Unit Page 1 of 1

## U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	Α	US-6,280,328 B1	08-2001	Holch et al.	463/42
*	В	US-2003/0195037 A1	10-2003	Vuong et al.	463/29
*	C	US-2003/0224854 A1	12-2003	Joao, Raymond Anthony	463/40
*	D	US-6,712,695 B2	03-2004	Mothwurf et al.	463/25
*	Е	US-2004/0048644 A1	03-2004	Gerrard et al.	463/016
*	F	US-6,935,958 B2	08-2005	Nelson, Dwayne	463/42
	G	US-			
	Ι	US-			
	-	US-			
	J	US-			
	K	US-			
	L	US-			
	М	US-			

## FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	0					
	Р					
	Ø					
	R					
	Ø					
	Т					

## **NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	w	
	х	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).) Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.